



Hill Donell &
R. Jones
8/1/03
2822

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Yeong-Kwan KIM, et al.

Serial No. 09/902,607

Filed: July 12, 2001

For: SEMICONDUCTOR DEVICE HAVING
THIN FILM FORMED BY ATOMIC LAYER
DEPOSITION AND METHOD FOR
FABRICATING THE SAME

Art Unit: 2822

Examiner: Toniae M. THOMAS

Confirmation No. 1299

Attorney Docket No. 249/258

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
United States Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action mailed May 21, 2003, please amend the application identified above as follows:

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